



IFW

Attorney's Docket No. 5649-1263

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Jung-Hun Seo et al.

Confirmation No.: 4965

Serial No.: 10/812,768

Group Art Unit: 2891

Filed: March 30, 2004

For: *Metal Deposition Apparatus Used in Fabrication of Semiconductor Devices and Methods of Forming Metal Layers Using the Same*

January 25, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

This is in response to the Election/Restriction Requirement of December 29, 2005 (the Action).

Applicants hereby elect the species of Group I, Claims 1-15 drawn to an apparatus, classified in class 118, subclass 715.

Substantive examination on the merits is respectfully requested.

Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 25, 2006.

Carey Gregory